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11.03.2021

# **Department of Electrical Engineering**

**Corrigendum-2** 

# Tender Reference no: EE/2021/043/ENAK/PEALD SYSTEM

#### Name of the Item: Plasma enhanced Atomic Layer Deposition (PEALD) system suitable for deposition of Al2O3, AlHfO, AlN, SiO2 and SiN

## **Corrigendum details: Extension of Bid Submission Date**

## **Extension of Bid Submission Date:**

The due date for the submission of bids has been extended to 18/03/2021 @ 5 PM & the technical bid opening is 19/03/2021 @ 4 PM

**Tender Inviting Authority:** 

The Senior Manager, Project Purchase, IC&SR Building, IIT Madras Chennai 600036